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SCI AUTOMATION

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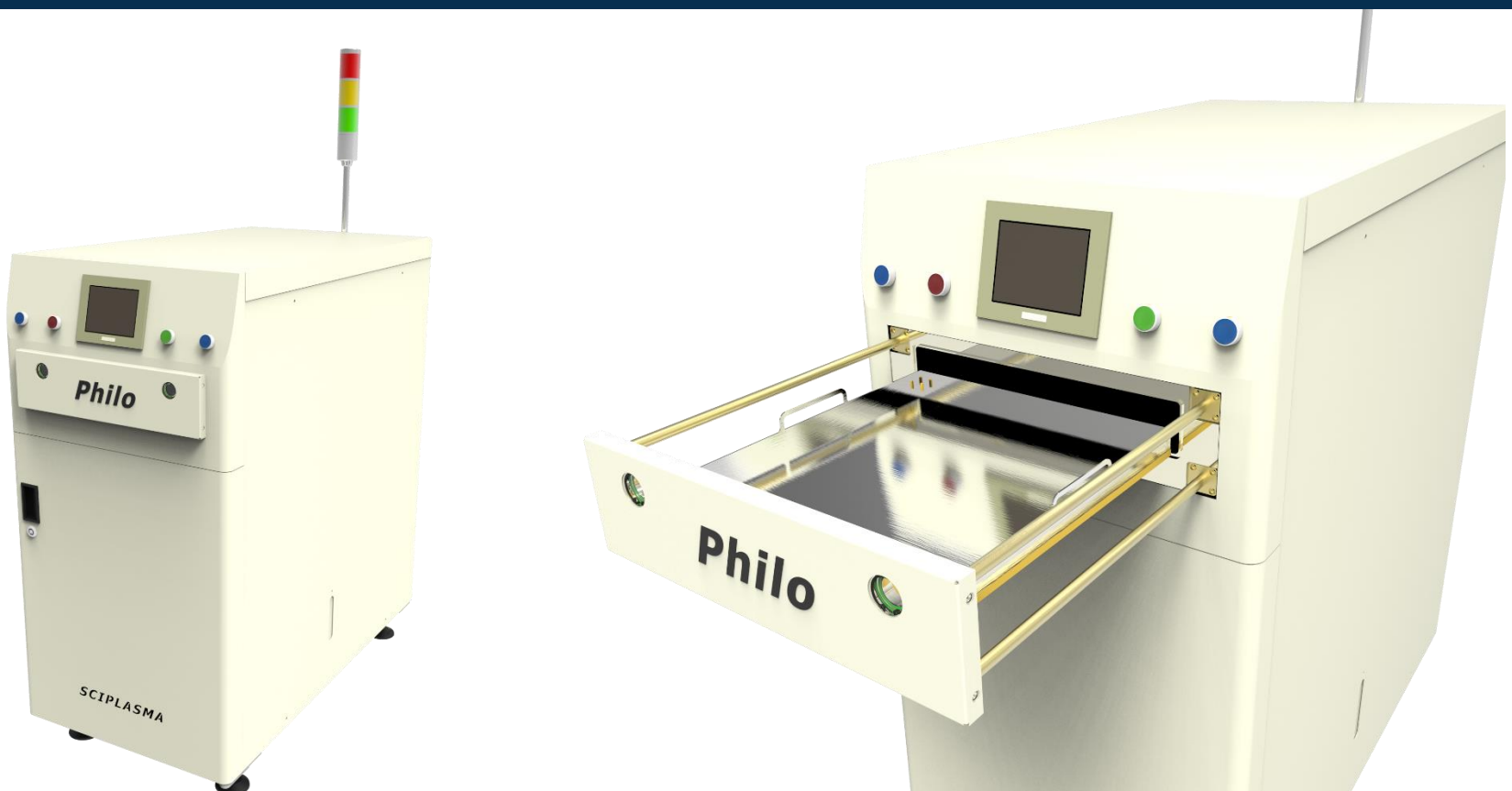
HAPPY NEW YEAR

Dear Reader,

Happy Lunar New Year! We wish you a prosperous and bountiful Year of the Dog!

In this month's issue, we explore the capabilities of one of our batch plasma cleaning systems, **PHILO** a compact standalone system, with a built-in automatic tray in its chamber.

PHILO



Philo can be used for general and wafer cleaning, activation and decontamination. The automated tray allows for ease of operation and ensures that your product is properly processed. With its innovative design, Philo is suitable to handle plasma cleaning of boats, printed circuit boards (PCBs), hybrid and custom substrates. It can also be used for hard disk and solar applications. Philo provides the ideal solution to activate a wafer's surface prior to wire-bonding.

BENEFITS OF PLASMA CLEANING

- Safe and environmentally-friendly alternative to using harsh chemicals on substrates to eliminate trace amounts of impurities and contaminants.
- As no harsh chemicals are used, there is no need to worry about chemical exposure to the operator.
- Does not leave surface residue.
- Cost-effective.

SCI provides inline, strip and batch systems for lead frames, substrates, wafers, and modules.

[View our products here!](#)

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